

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toshimitsu Taniguchi et al.

Art Unit : 2825

Serial No.: 09/891,580

Examiner: Igwe U. Anya

Filed : June 26, 2001

Title : SEMICONDUCTOR DEVICE MANUFACTURING METHOD.

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed. A copy of a communication from a foreign patent office in a counterpart application is also enclosed.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. I, the undersigned, hereby certify that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application, the communication being dated May 27, 2003, which is not more than three months prior to the filing of this statement. Please apply any charges or credits to Deposit Account No. 06-1050.

AUG -8 2003

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

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Attorney & Docket No.: 10417-085001 / F51-134750M/SW

Respectfully submitted,

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Date: August 4, 2003

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